



2821

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor Applicant:

Harry Q. Pon

Serial No.: 09/836,973

Filed: April 18, 2001

For: EMI and Noise Shielding for Multi-Metal Layer High Frequency Integrated Circuit Processes

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Art Unit: 2821

Examiner: Minh D. A

Docket: ITL.0452US
P9563

Mail Stop **Non-Fee Amendment**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO PAPER NO. 4

Sir:

In response to the office action mailed February 12, 2004, please amend the above-referenced patent application as follows:

Date of Deposit: March 24, 2004

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
Cynthia L. Hayden